

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: HONGO, et al.

Serial No.: Not yet assigned

Filed: July 29, 2003

For: DISPLAY DEVICE PROCESS AND APPARATUS FOR ITS
PRODUCTION

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 29, 2003

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of a communication from a foreign patent office in a counterpart foreign application and copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted with the new application.

Although some of the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by the attached English language abstracts, and the discussion of the documents in the specification, for example, on page five (5).

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case: 1113.42986X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

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Attachments

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DKT. NO. 1113.42986X00	SERIAL NO.
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		APPLICANT HONGO, et al.	
		FILING DATE July 29, 2003	GROUP

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Abstract	
						Yes	No
	AM	2002-222959	08/09/2002	JP	H01L 29/786	X	
	AN	5-283356	10/29/1993	JP	H01L 21/268	X	
	AO	7-335547	12/22/1995	JP	H01L 21/20	X	
	AP	2000-243970	09/08/2000	JP	H01L 29/786	X	
	AQ						
	AR						
	AS						
	AT						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AU	TAKEUCHI, et al., "Performance of Poly-Si TFTs Fabricated by a Stable Scanning CW Laser Crystallization", TFT4-3, Pgs. 251-254
	AV	
	AW	
	AX	
	AY	
	AZ	
Examiner		Date Considered